IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Group Art Unit: N/A

Grimbergen, et al.

Examiner: Unknown

Serial No.: N/A

Docket No.:

Filed: Herewith

2077.D1/USA/SILICON/MBE

For: APPARATUS AND METHOD

June 13, 2000

FOR MONITORING PROCESSING

OF A SUBSTRATE

San Francisco, California

INFORMATION DISCLOSURE STATEMENT

Box PATENT APPLICATION
Assistant Commissioner for Patents
Washington, D.C. 20231

Sir/Madam:

Attached hereto is a PTO-1449 form listing documents believed relevant to the subject application. It is respectfully requested that these documents be considered by the Examiner and an initialed copy of the form be returned to the undersigned.

A copy of each newly submitted document is enclosed. References marked with a star were previously submitted in the U.S. Patent Serial No. 08/944,240, filed October 6, 1997, of which this application is a divisional. Therefore, copies of these references are not being submitted herewith.

It should be noted that the word "prior" has been deleted from the form.

It is believed that this disclosure complies with the requirements of 37 C.F.R. §§ 1.56, 1.97 and 1.98, and the Manual of Patent Examining Procedures § 707.05(b). If for some reason the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.

Some of the documents may have markings thereon. No significance is meant to be attached to the markings.

With regard to any translations which may be provided herewith, the undersigned does not know how and who made the translations. Therefore, no representation is being made as to the accuracy of any translation.

These documents are not necessarily analogous.

Respectfully submitted,

JANAH & ASSOCIATES A PROFESSIONAL CORPORATION

Date: 6/13/00

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Encls.